Adaptive Tangential Relaxation and Surface Fitting for High-Order Mesh Optimization

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Vladimir Z Tomov P. Knupp, Tz. Kolev and K. Mittal

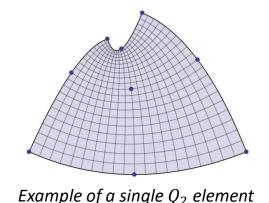


Goal: derive mesh optimization methods based on finite element operations

The mesh positions are represented as a FE function.

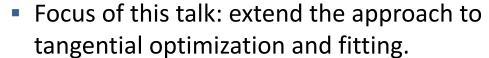
$$m{x} = (m{x}_1 \dots m{x}_N)^T, \quad x_q(\bar{x}_q) = \sum_{i=1}^N m{x}_i \bar{w}_i(\bar{x}_q)$$

$$A_q(x) = \frac{\partial x_q}{\partial \bar{x}_q} = \sum_{i=1}^N m{x}_i [\nabla \bar{w}_i(\bar{x}_q)]^T$$

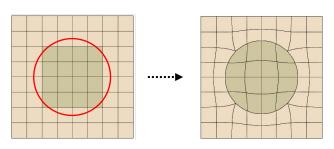


Node movement with fixed topology.

- Generality w.r.t. dimension and element type.
- Avoid geometric operations.
- Computational performance.







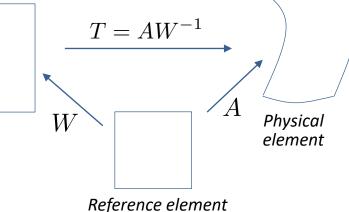
Example of fitting through node movement



Approach overview: Target-Matrix Optimization Paradigm (TMOP) and variational minimization

Target element

- Target construction: the user defines ideal target elements by specifying the target Jacobians W.
- The Jacobian T is used to define the local mesh quality measure $\mu(T)$.
- Combinations of W and $\mu(T)$ control various properties of the physical elements. W = [volume] [orientation] [skew] [aspect ratio].



• Variational minimization over the target elements (solving $\partial F(x) / \partial x = 0$):

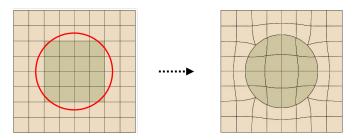
$$F(x) := \sum_{E \in \mathcal{M}} \int_{E_t} \mu(T(x_t)) dx_t = \sum_{E \in \mathcal{M}} \sum_{x_q \in E_t} w_q \det(W(\bar{x}_q)) \mu(T(x_q))$$

Dobrev, Knupp, Kolev, Mittal, Tomov, "The Target-Matrix Optimization Paradigm for high-order meshes", SISC, 2019 Knupp, "Metric Type in the Target-matrix Mesh Optimization Paradigm" LLNL-TR-817490, 2020.

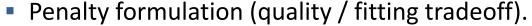


Fitting and tangential relaxation are enforced weakly by a variational penalty term

 The surface of interest is given as a discrete level set (no analytic parametrization).



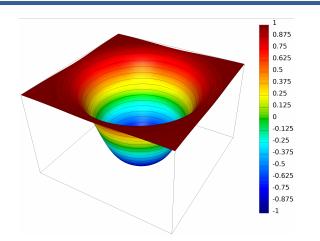
Example of 2D interface fitting

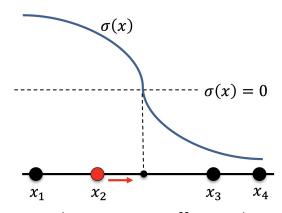


- All mesh nodes move simultaneuously.
- One approach for fitting / tangential relaxation.

$$F(x) = F_{\mu} + w_{\sigma} \int_{\Omega} \bar{\sigma}(x)^{2}$$

- The restricted level set function $\bar{\sigma}$ penalizes the deviation from the zero level set.
 - Marking is not a trivial procedure.





The extra term affects only the position of the red DOF



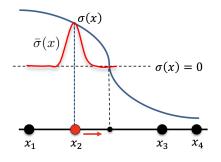


The penalty term is put in a form that can be easily differentiated

• We restrict σ to the set of marked nodes:

$$\bar{\sigma}_i = \begin{cases} \sigma_i & \text{if } i \in \mathcal{S}, \\ 0 & \text{otherwise.} \end{cases}$$

- Goal: move the mesh so that $\sigma_i \equiv \sigma(x_i) = 0$.
 - Interpolatory finite element basis functions.
 - The nodes of x and σ must coincide.



• The derivative computation must see the term $\partial \sigma_i \setminus \partial x \neq 0$.

$$\bar{\sigma}(\boldsymbol{x}) = \sum_{i \in \mathcal{S}} \sigma_i \phi_i(\boldsymbol{x}) = \sum_{s \in \mathcal{S}} \sum_{k=1}^{N_x} \sigma_k \phi_k(\boldsymbol{x_i}) \phi_i(\boldsymbol{x}).$$

$$Derivatives of this term represent the changes of σ as the mesh evolves$$

• Field remap — required as σ is a discrete FE function.

Dobrev, Knupp, Kolev, Tomov, "Towards simulation-driven optimization of high-order meshes by TMOP", IMR, 2019.





Derivatives of the penalization term are calculated through standard FE operations

$$\begin{split} \frac{\partial F_{\sigma}}{\partial x_{a,i}} &= \frac{2\omega_{\sigma}}{c_{\sigma}} \int_{E_{t}} \bar{\sigma}(\boldsymbol{x}) \frac{\partial \bar{\sigma}(\boldsymbol{x})}{\partial x_{a}} \frac{\partial x_{a}}{\partial x_{a,i}} \\ &= \frac{2\omega_{\sigma}}{c_{\sigma}} \int_{E_{t}} \bar{\sigma}(\boldsymbol{x}) \sum_{s \in \mathcal{S}} \sum_{k} \sigma_{k} \bigg(\frac{\partial \phi_{k}(\boldsymbol{x_{s}})}{\partial x_{a}} \phi_{s}(\boldsymbol{x}) + \\ &\qquad \qquad \phi_{k}(\boldsymbol{x_{s}}) \frac{\partial \phi_{s}(\boldsymbol{x})}{\partial x_{a}} \bigg) w_{i}(\bar{\boldsymbol{x}}), \end{split}$$

$$\begin{split} \frac{\partial^{2} F_{\sigma}}{\partial x_{b,j} \partial x_{a,i}} &= \frac{2\omega_{\sigma}}{c_{\sigma}} \int_{E_{t}} \left(\frac{\partial \bar{\sigma}(\boldsymbol{x})}{\partial x_{b}} \frac{\partial \bar{\sigma}(\boldsymbol{x})}{\partial x_{a}} + \right. \\ & \left. \bar{\sigma}(\boldsymbol{x}) \frac{\partial^{2} \bar{\sigma}(\boldsymbol{x})}{\partial x_{b} \partial x_{a}} \right) \frac{\partial x_{a}}{\partial x_{a,i}} \frac{\partial x_{b}}{\partial x_{b,i}} \\ &= \frac{2\omega_{\sigma}}{c_{\sigma}} \int_{E_{t}} \left(\mathcal{D}_{a} \mathcal{D}_{b} + \bar{\sigma}(\boldsymbol{x}) \mathcal{D}^{2} \right) w_{i}(\bar{\boldsymbol{x}}) w_{j}(\bar{\boldsymbol{x}}), \end{split}$$

where

$$\mathcal{D}_{*} = \sum_{s \in \mathcal{S}} \sum_{k} \sigma_{k} \left(\frac{\partial \phi_{k}(\boldsymbol{x}_{s})}{\partial x_{*}} \phi_{s}(\boldsymbol{x}) + \phi_{k}(x_{s}) \frac{\partial \phi_{s}(\boldsymbol{x})}{\partial x_{*}} \right),$$

$$\mathcal{D}^{2} = \sum_{s \in \mathcal{S}} \sum_{k} \sigma_{k} \left(\frac{\partial \phi_{k}(\boldsymbol{x}_{s})}{\partial x_{a}} \frac{\partial \phi_{s}(\boldsymbol{x})}{\partial x_{b}} + \frac{\partial^{2} \phi_{k}(\boldsymbol{x}_{s})}{\partial x_{b} \partial x_{a}} \phi_{s}(\boldsymbol{x}) + \frac{\partial \phi_{k}(\boldsymbol{x}_{s})}{\partial x_{b}} \frac{\partial \phi_{s}(\boldsymbol{x})}{\partial x_{b}} + \phi_{k}(\boldsymbol{x}_{s}) \frac{\partial^{2} \phi_{s}(\boldsymbol{x})}{\partial x_{b} \partial x_{a}} \right),$$

$$a, b = 1 \dots d, \quad i, j = 1 \dots N_{x}.$$

Knupp, Kolev, Mittal, Tomov, "Adaptive surface fitting and tangential relaxation for high-order mesh optimization", IMR, 2021.





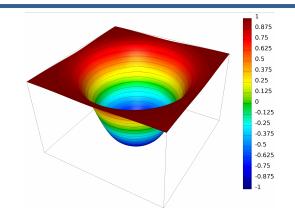


The method behaves as expected on academic problems with smooth interfaces

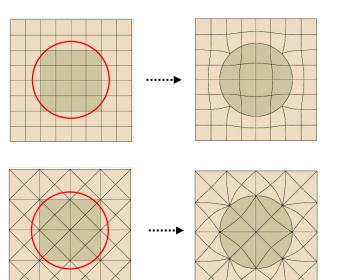
- In all cases σ is a discrete FE function.
 - Ball at the center of the domain.

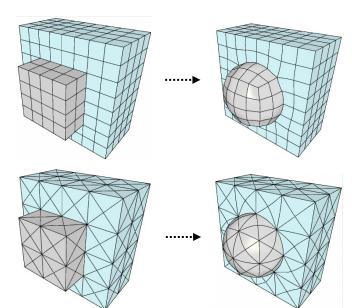
2D metric:
$$\mu_{80}=(1-\gamma)\left(0.5rac{|T|^2}{ au}-1
ight)+\gamma\left(0.5\left(au-rac{1}{ au}
ight)^2
ight)$$

3D metric:
$$\mu_{333} = (1-\gamma)\left(\frac{|T|^2|T^{-1}|^2}{9}-1\right) + \gamma\left(0.5\left(\tau + \frac{1}{\tau}\right) - 1\right)$$



P. Knupp, "Metric Type in the Target-matrix Mesh Optimization Paradigm" LLNL-TR-817490, 2020.

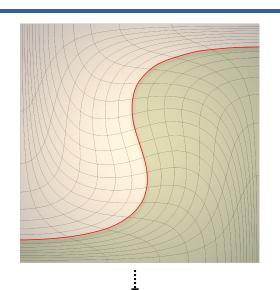


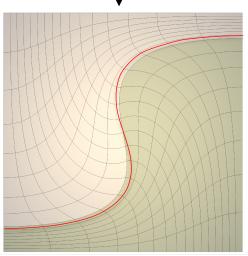


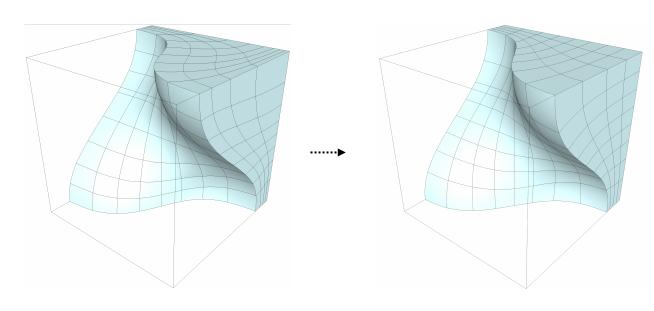




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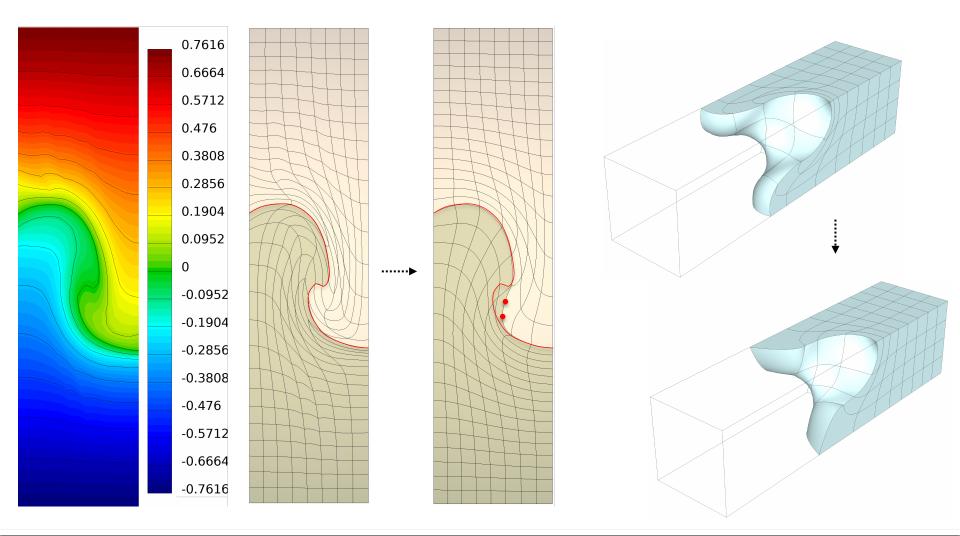




Approach	F decrease	\mathcal{E}_{avg}	\mathcal{E}_{max}
Fixed interface	34.4%	0	0
$w_{\sigma} = 250$	51.4%	8.2e-2	1.3e-1
$w_{\sigma} = 1000$	42.6%	3.6e-2	6.4e-2



For non-smooth practical cases, further research and methods are required



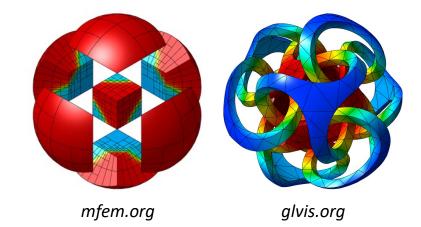






MFEM open source implementation

- All presented methods are (or will be) available in MFEM.
- MFEM contains 12 2D metrics,
 7 3D metrics, all metric derivatives,
 6 target construction methods.



- User interface provided by the mesh_optimizer and pmesh_optimizer miniapps.
 - Choice of target construction / quality metric / adaptivity fields / parameters.
 - Visualization through GLVis.

Dobrev, Knupp, Kolev, Mittal, Tomov, "The Target-Matrix Optimization Paradigm for high-order meshes", SIAM J. Sci. Comp., 2019.

Dobrev, Knupp, Kolev, Mittal, Rieben, Tomov, "Simulation-driven optimization of high-order meshes in ALE hydrodynamics", Comput. Fluids, 2020.

Knupp, Kolev, Mittal, Tomov, "Adaptive surface fitting and tangential relaxation for high-order mesh optimization", IMR, 2021.



Summary and future work

- Surface fitting and tangential relaxation through an adaptive FE formulation.
 - Discrete representation of the surface; no analytic parametrization.
 - Exploratory attempt to use FE-only operations.
- Weak enforcement through a variational penalty term.
 - Simultaneous optimization of surface and non-surface nodes.
 - Applicable to both fitting and tangential relaxation.
- Derivatives are computed through standard FE operations.
- Behaves as expected on smooth surfaces.
- Future work robust behavior for practical non-smooth problems.





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